

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Akira Hagiwara et al.

Serial No. 10/828,456

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For: RADIATION COMPUTED

TOMOGRAPHY APPARATUS

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**CERTIFICATE OF MAILING** 

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## STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

The above-identified patent application was filed on April 20, 2004. Applicants respectfully request a status inquiry on the above-identified patent application.

Respectfully submitted,

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